

Internal Photoemission Mechanisms at Interfaces Between Germanium and Thin Metal Films

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Abstract—The quantum efficiency associated with the internal photoemission of electrons over the Schottky barrier (of height ϕ_B) at the metal-Ge interface has been studied experimentally for several metals (Au, Cu, Ag, Pb, and Ni). A theoretical description of this mechanism has been developed in which we take into account the front and back optical absorptance, hot electron scattering, and multiple reflections of excited electrons from the surfaces of the thin electrode film. We have found it necessary to impose a modification of the Fowler theory of photoemission when applied to internal photoemission from thin metal films over a Schottky barrier. This modification relates to an enhanced photoexcitation within the metal films which is attributed in the present theory to a density of states which exhibits a peaked distribution in energy rather than the simple parabolic bands assumed by Fowler. It is clear from the present study that the majority of photoelectron excitation occurs from a small region of energy of the order of a fraction of an electron volt near the Fermi energy. The theoretical model presented here defines two important parameters: a hot-electron mean free path (L_e) and an energy (E_{ef}) given by the difference between the Fermi level and the effective conduction band minimum associated with the region of energy in the metal near the Fermi level where the electron distribution is strongly peaked. Values of L_e for Au is 550 Å, Ag is 570 Å, Cu is 450 Å, and Pb is 55 Å. E_{ef} for Au is 0.1 eV, Ag is 0.152 eV, Cu is 0.11 eV, Pb is 0.1 eV. The validity of this model is confirmed by the experimental finding that the parameters L_e and E_{ef} are independent of metal thickness.

INTRODUCTION

THERE has been substantial recent research interest associated with novel detectors operating in the infrared region [1]–[4]. We have presented several modes of photoexcitation in Ge Schottky barriers in previous publications [5]–[7]. The present paper is concerned with the internal photoemission of electrons from thin metal films over the Schottky barrier (ϕ_B) at the metal-Ge interface. Shown in Fig. 1 is the energy band diagram and the corresponding E - K dispersion relation of the metal-Ge Schottky barrier structure. The mechanisms illustrated by arrows 1 and 2 are the band to band transitions of electrons in the Ge substrate. These mechanisms are employed for detection of photons of energy $h\nu > 0.67$ eV, the indirect energy gap of Ge, and are the usual mode of operation for these devices. A full account of the quantum efficiency associated with these band to band processes 1 and 2 is reported in another publication [7]. We discuss here the quan-

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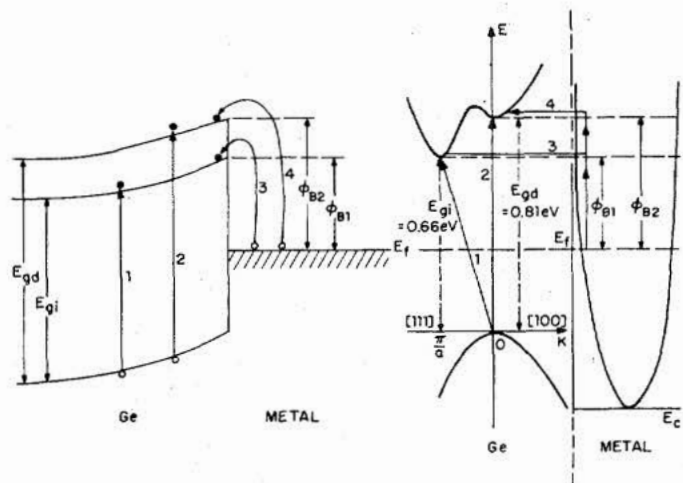


Fig. 1. Energy band diagram and dispersion (E - K) relation for metal-Ge Schottky barrier. Arrows 1, 2, 3, and 4 indicate the four possible electron transition mechanisms.

tum efficiency associated with the mechanisms indicated by arrows 3 and 4 in Fig. 1 which correspond to the optical excitation of electrons in the metal followed by the scattering of these electrons into the Ge conduction band. These processes are termed internal photoemission. The standard theory of photoemission from a metal into the vacuum is due to Fowler [8]. This theory assumes that the density of states in the metal is described by the normal parabolic distribution associated with the nearly free electron approximation. Thus in Fowler's theory, the Fermi energy is several electron volts above the conduction band minimum and a single band is considered.

It is known, however (see, for example, [9]), that a realistic description of the density of states in a metal does not follow this simple distribution, but rather shows a distribution with many peaks as a consequence of overlapping bands, nonparabolicity, and deviations in thin metal films from perfect crystalline order. The approach we adopt in the present paper comes to terms with these deviations from ideal behavior by assigning an effective conduction band edge, which is close to the Fermi energy, and which represents the large density of states assumed to exist in the vicinity of the Fermi energy. Thus, we arrive at a modified version of Fowler's theory which is in close agreement with experimental data obtained in this study for internal photoemission from several thin metal films into the conduction band of single crystalline germanium. In addition, the present theory is able to derive quantitative information about the mean free path of photoexcited (hot) electrons with energy well above the Fermi level.

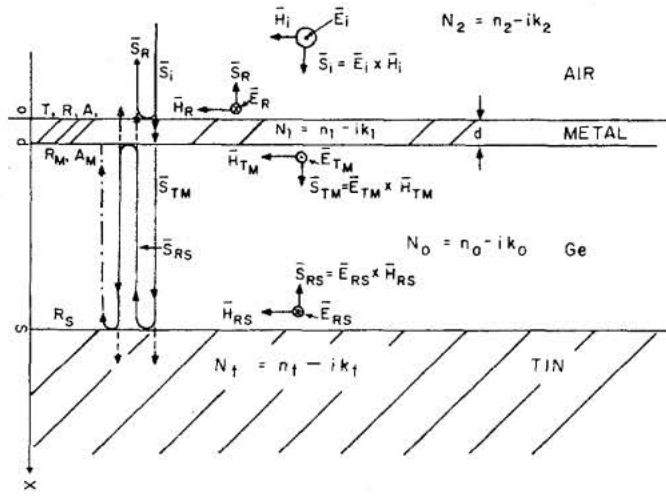


Fig. 2. Schematic diagram for optical properties of metal-Ge Schottky barrier structures. \vec{E} , \vec{H} are electric and magnetic fields of the optical radiation and \vec{S} is the Poynting vector which indicates the direction of power flow. Solid line inside the Ge layer indicates the path for multiple reflection of the transmitted photons. T, R, A are the transmittance, reflectance, and absorptance at the air-metal interface; R_M, A_M are the reflectance and absorptance at the Ge-metal interface; R_s is the reflectance of the thick tin back contact.

THEORY OF INTERNAL PHOTOEMISSION

The external quantum efficiency (η_0) of a metal-Ge Schottky barrier associated with internal photoemission can be written as

$$\eta_0 = A_T F_e P_E \quad (1)$$

where A_T is the total optical absorptance of the metal electrode, F_e is the fraction of the absorbed photons which produce photoelectrons with the appropriate energy and momenta before scattering to contribute to the photocurrent, and P_E is the total accumulated probability that one of these photoexcited electrons will be able to overcome ϕ_B after scattering with cold electrons and with the two boundary surfaces. These three factors are determined as follows.

A. Mathematical Formulation for Optical Absorptance A_T

In order to calculate A_T , the optical properties of the present metal-Ge Schottky barrier structures are schematically represented in Fig. 2. The device is illuminated from the air side with optical radiation that is normally incident. N_2, N_1, N_0 , and N_t are the complex indices of refraction of the air, metal, Ge, and the tin back contact. Small n 's are the real part of N 's, small k 's are the extinction coefficients which are the imaginary part of N 's. The respective optical constants (n 's and k 's) used in the following calculations are summarized in Table I. The optical reflectance (R), absorptance (A), and transmittance (T) are calculated by a two-layer model as follows (see, for example, Heavens [10]):

$$T = \frac{n_0}{n_2} t_i t_i^* \quad (2)$$

$$R = r_i r_i^* \quad (3)$$

$$A = 1 - (T + R) \quad (4)$$

TABLE I
OPTICAL CONSTANTS USED FOR THE COMPUTER CALCULATION IN THE SPECIFIED PHOTON ENERGY RANGE

| MATERIAL | n | k |
|---------------------------|-------|-------|
| Air | 1.0 | 0.0 |
| Ge | 4.0 | 0.0 |
| Tin | 2.0 | 17.5 |
| Au at $d=50 \text{ \AA}$ | 0.2 | 15.2 |
| Au at $d=100 \text{ \AA}$ | 0.16 | 11.0 |
| Cu at $d=100 \text{ \AA}$ | 0.145 | 11.6 |
| Cu at $d=300 \text{ \AA}$ | 0.137 | 11.05 |
| Ag at $d=100 \text{ \AA}$ | 0.45 | 9.3 |
| Ag at $d=200 \text{ \AA}$ | 0.56 | 12.0 |
| Ag at $d=300 \text{ \AA}$ | 0.52 | 11.1 |
| Pb at $d=300 \text{ \AA}$ | 2.1 | 9.8 |

$0.63 \text{ eV} \lesssim h\nu \lesssim 0.68 \text{ eV}$
 $N = n - ik$

where r_i and t_i are the reflection and transmission coefficients of the metal-air interface

$$r_i = \frac{r_2 + r_1 \exp(-2i\delta_1)}{1 + r_1 r_2 \exp(-2i\delta_1)} \quad (5)$$

$$t_i = \frac{t_1 t_2 \exp(-i\delta_1)}{1 + r_1 r_2 \exp(-2i\delta_1)} \quad (6)$$

$$\delta_1 = \frac{2\pi}{\lambda} d_1 N_1 \quad (7)$$

$$r_1 = \frac{N_1 - N_0}{N_1 + N_0} \quad (8)$$

$$r_2 = \frac{N_2 - N_1}{N_2 + N_1} \quad (9)$$

$$t_1 = \frac{2N_1}{N_1 + N_0} \quad (10)$$

$$t_2 = \frac{2N_2}{N_1 + N_2} \quad (11)$$

and where λ is the wavelength of the incident radiation and d_1 is the thickness of the metal film.

For $h\nu \leq 0.66 \text{ eV}$, the Ge substrate can be assumed to be transparent to the incident radiation. These transmitted photons in the Ge are multiply reflected between the metal and the tin back contact as indicated in Fig. 2. We define T_M, R_M , and A_M as the transmittance, reflectance, and absorptance within the metal, of photons incident on the metal film from the germanium substrate; again, using a two-layer calculation we have that

$$T_M = \frac{n_2}{n_0} t_b t_b^* \quad (12)$$

$$R_M = r_b r_b^* \quad (13)$$

$$A_M = 1 - (T_M + R_M) \tag{14}$$

$$r_b = \frac{r_0 + r_{10} \exp(-2i\delta_1)}{1 + r_{10}r_0 \exp(-2i\delta_1)} \tag{15}$$

$$t_b = \frac{t_0 t_{10} \exp(-i\delta_1)}{1 + r_0 r_{10} \exp(-2i\delta_1)} \tag{16}$$

$$r_{10} = \frac{N_1 - N_2}{N_1 + N_2} \tag{17}$$

$$r_0 = \frac{N_0 - N_1}{N_0 + N_1} \tag{18}$$

$$t_{10} = \frac{2N_1}{N_1 + N_2} \tag{19}$$

$$t_0 = \frac{2N_0}{N_0 + N_1} \tag{20}$$

The reflectance (R_t) of the thick tin back contact can be approximated by a one-layer calculation as follows:

$$r_t = \frac{N_0 - N_t}{N_0 + N_t} \tag{21}$$

$$R_t = r_t r_t^* \approx 90 \text{ percent.} \tag{22}$$

The additional optical absorptance (A_B) of the metal film due to multiple scattering of the photons originally transmitted into the Ge substrate is given as

$$\begin{aligned} A_B &= TR_t A_M + TR_t^2 R_M A_M + RT_t^3 R_M^2 A_M \\ &\quad + TR_t^4 R_M^3 A_M + \dots \\ &= TA_M R_t [1 + R_t R_M + (R_t R_M)^2 + (R_t R_M)^3 + \dots] \\ &= TA_M R_t \left(\frac{1}{1 - R_t R_M} \right) \end{aligned} \tag{23}$$

$$\therefore A_T = A + A_B. \tag{24}$$

B. Mathematical Formulation for F_E

The nearly free electron gas in a metal obeys Fermi-Dirac statistics; the number of electrons per unit volume having velocity components in the range $u, u + du, v, v + dv,$ and $w, w + dw$ (u normal to metal-Ge interface) is given by the well-known formula used in the standard Fowler theory [8]

$$n(u, v, w) du dv dw = 2 \left(\frac{m}{h} \right)^3 \frac{du dv dw}{e^{[\frac{1}{2}m(u^2+v^2+w^2) - E_F]/kT} + 1} \tag{25}$$

where m is the effective mass of the electron, h is Planck's constant, and E_F is the Fermi energy level measured from the conduction band minimum E_c (Fig. 1). Assuming uniform absorption of photons throughout the thin metal film as a consequence of weak absorption (7), the total number of electrons per unit volume (N_T) that are candidates for photoexcitation is

$$N_T = 8\pi \left(\frac{m}{h} \right)^3 \int_{\frac{1}{2}m\rho^2 = E_F - h\nu}^{\infty} \frac{\rho^2 d\rho}{e^{(\frac{1}{2}m\rho^2 - E_F)/kT} + 1} \tag{26}$$

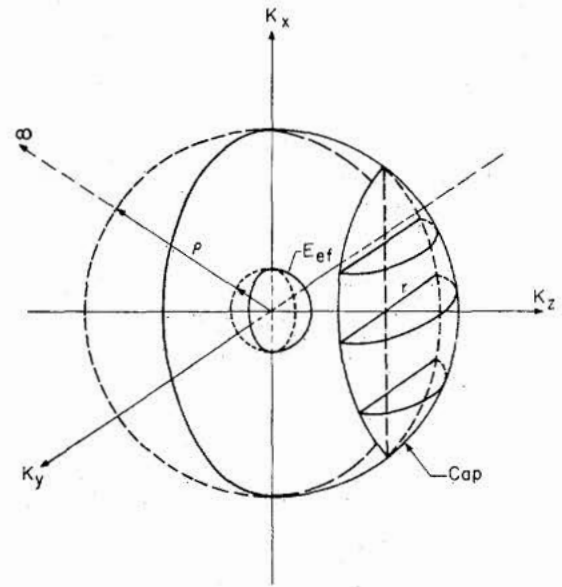


Fig. 3. Three-dimensional E - K relation for the free electron gas of metal; each sphere corresponds to a constant energy surface. Volume of the cap corresponds to the fraction of electrons which can overcome the Schottky barrier height.

where $\rho = (u^2 + v^2 + w^2)^{1/2}$ and is proportional to the radius of the constant energy sphere indicated in Fig. 3. $h\nu$ is the incident photon energy. In this paper, we depart from the standard Fowler theory of (26) by assuming, as described above, that photoexcitation occurs only from those states belonging to the peak near the Fermi energy. This assumption is justified from an examination of our experimental data and implies that for the metals studied here the density of states is relatively strongly peaked near the Fermi energy. For ease of calculation, we assume that the density of states nevertheless follows a parabolic distribution but with an effective conduction band minimum E'_c which is close to the Fermi level. We, therefore, refer the Fermi energy to E'_c so that $E_{ef} = E_F - E'_c$. In the present theory, N_T is therefore given as

$$N_T = 8\pi \left(\frac{m}{h} \right)^3 \int_{\frac{1}{2}m\rho^2 = E_F - E_{ef}}^{\infty} \frac{\rho^2 d\rho}{e^{(\frac{1}{2}m\rho^2 - E_F)/kT} + 1} \tag{27}$$

Taking $E_F \rightarrow E_{ef}$ (E'_c is now the zero of energy), N_T will correspond to the volume given by the sphere of Fig. 3, then

$$\begin{aligned} N_T &= 8\pi \left(\frac{m}{h} \right)^3 \int_0^{\infty} \frac{\rho^2 d\rho}{e^{(\frac{1}{2}m\rho^2 - E_{ef})/kT} + 1} \\ &= 8\sqrt{2} \pi \frac{(m)^{3/2}}{h^3} (kT)^{3/2} I(E_{ef}) \end{aligned} \tag{28}$$

where

$$I(E_{ef}) = \int_0^{\infty} \frac{y^{1/2} dy}{e^{y - E_{ef}/kT} + 1}$$

and

$$y = \frac{1}{kT} \left(\frac{1}{2} m \rho^2 \right).$$

As explained by Fowler [8], only those electrons whose kinetic energy normal to the metal-Ge interface augmented by $h\nu$ is sufficient to overcome the barrier height (ϕ_B) will contribute to the photocurrent in the device. The number of these electrons correspond to the "cap" volume indicated in the constant energy sphere of Fig. 3 and is given as

$$N_B = \int_{\frac{1}{2}mu^2 = E_{ef} + \phi_B - h\nu}^{\infty} \bar{n}(u) du \quad (29)$$

where $\bar{n}(u)$ is the number of electrons per unit volume having a velocity component normal to the metal-Ge interface in the range $u, u + du$, given by

$$\begin{aligned} \bar{n}(u) du &= 2 \left(\frac{m}{h}\right)^3 du \int_0^{\infty} \int_0^{2\pi} \frac{r dr d\theta}{e^{[\frac{1}{2}m(u^2+r^2) - E_{ef}]/kT} + 1} \\ &= \frac{4\pi kT}{m} \left(\frac{m}{h}\right)^3 \log \{1 + e^{(E_{ef} - \frac{1}{2}mu^2)/kT}\} du. \end{aligned} \quad (30)$$

By making a change of variables and substituting (30) into (29), with $y = (h\nu - \phi_B - E_{ef} + \frac{1}{2}mu^2)/kT$, we have that

$$\begin{aligned} N_B &= \frac{2\pi kT}{m} \left(\frac{2kT}{m}\right)^{1/2} \left(\frac{m}{h}\right)^3 \\ &\cdot \int_0^{\infty} \frac{\log \{1 + e^{-y + (h\nu - \phi_B)/kT}\}}{[y + (E_{ef} + \phi_B - h\nu)/kT]^{1/2}} dy. \end{aligned} \quad (31)$$

To simplify the integral in (31), we consider the region of $h\nu$ near ϕ_B ($h\nu \doteq \phi_B$); it then becomes a good approximation to neglect y in the denominator of the integrand of (31); therefore,

$$\begin{aligned} N_B &\simeq \frac{2\sqrt{2} \pi m^{3/2}}{h^3} \frac{k^2 T^2}{(E_{ef})^{1/2}} \\ &\cdot \int_0^{\infty} \log \{1 + e^{-y + (h\nu - \phi_B)/kT}\} dy. \end{aligned} \quad (32)$$

For

$$\begin{aligned} t &= \frac{h\nu - \phi_B}{kT} \geq 0 \\ N_B &\simeq \frac{2\sqrt{2} \pi m^{3/2} k^2 T^2}{h^3 (E_{ef})^{1/2}} \\ &\cdot \left[\frac{1}{2} t^2 + \frac{\pi^2}{6} - \left\{ e^{-t} - \frac{e^{-2t}}{2^2} + \frac{e^{-3t}}{3^2} + \dots \right\} \right] \\ \therefore N_B &\simeq \frac{\sqrt{2} \pi m^{3/2}}{h^3 (E_{ef})^{1/2}} \left[(h\nu - \phi_B)^2 + \frac{k^2 T^2 \pi^2}{3} \right]. \end{aligned} \quad (33)$$

So the fraction of the absorbed photons which produce photoelectrons with the appropriate energy and momenta before scattering to contribute to the photocurrent is

$$F_e \simeq \frac{N_B}{N_T} = \frac{1}{8E_{ef}^{1/2} (kT)^{3/2} I(E_{ef})} \left[(h\nu - \phi_B)^2 + \frac{k^2 T^2 \pi^2}{3} \right]. \quad (34)$$

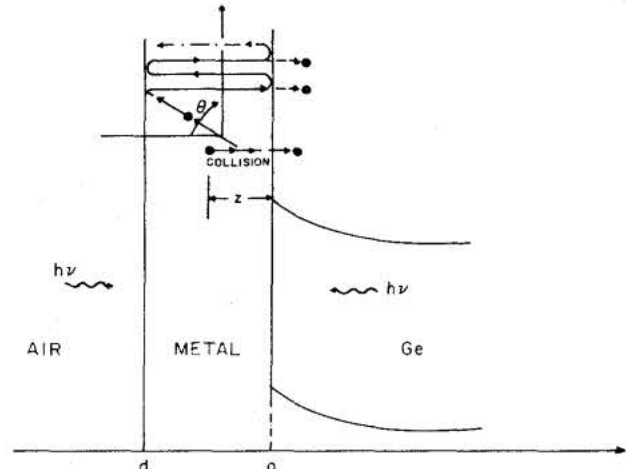


Fig. 4. Schematic diagram of a metal-Ge contact showing the scattering mechanism in the metal film. Solid line indicates the path for multiple scattering, broken lines indicate those electrons which can survive the scattering and be collected by the metal-Ge interface.

C. Mathematical Formulation for P_E

The efficiency of collecting those electrons which have sufficient normal kinetic energy to overcome ϕ_B will depend on their probability of collisions with the cold electrons and with the two boundary surfaces of the metal. The probability of a collision with the cold electrons is described by a mean free path L_e . As shown in Fig. 4, the Schottky barrier is illuminated through the front surface of the metal electrode. Since the optical absorption has been assumed uniform throughout the metal thickness, as justified in [7], the average probability of photoexcited electrons arriving at the semiconductor surface without collisions is

$$\begin{aligned} p_t &= \frac{1}{d} \int_0^d \exp(-z/L_e) dz \\ &= \frac{L_e}{d} [1 - \exp(-d/L_e)] \end{aligned} \quad (35)$$

where d is the metal thickness. Those electrons which have sufficient energy to overcome ϕ_B after one collision with the cold electrons are oriented with equal probability over the entire half-sphere before reflection by the metal surfaces; their accumulated probability of arrival at the reflection boundary is given by Vickers [11] as

$$\begin{aligned} p_r &= \frac{1}{d} \int_0^d \int_0^{\pi/2} \exp[-(d-z)/L_e \cos \theta] \sin \theta d\theta dz \\ &= \frac{1}{d} \int_0^d \int_0^{\infty} \{\exp[-t(d-z)/L_e] / t^2\} dt dz \\ &= \frac{1}{d} \int_0^d E_2 [(d-z)/L_e] dz \\ &= \frac{L_e}{d} \left[\frac{1}{2} - E_3(d/L_e) \right] \end{aligned} \quad (36)$$

where E_2 and E_3 are exponential integrals. For multiple re-

TABLE II
 SUMMARY OF RESULTS OBTAINED FROM FIGS. 7-10

| d (Å) | L _e (Å) | | | | φ _B (eV) | | | | E _{ef} (eV) | | | |
|-------|--------------------|-----|-----|----|---------------------|------|-------|-------|----------------------|-------|------|-----|
| | Au | Ag | Cu | Pb | Au | Ag | Cu | Pb | Au | Ag | Cu | Pb |
| 50 | 550 | | | | 0.56 | | | | 0.1 | | | |
| 100 | 550 | 570 | 450 | | 0.55 | 0.54 | 0.512 | | 0.1 | 0.152 | 0.11 | |
| 200 | | 570 | | | | 0.54 | | | | 0.152 | | |
| 300 | | 570 | 450 | 55 | | 0.54 | 0.493 | 0.535 | | 0.152 | 0.11 | 0.1 |

flections, the probability that the capturable electrons can bounce from one metal boundary to another is given as

$$p = E_2(d/L_e). \quad (37)$$

The total accumulated probability that those electrons which have sufficient normal kinetic energy to overcome φ_B will contribute to the photocurrent is then

$$P_E = p_t + p_r(1 + p + p^2 + p^3 + \dots) \exp(-d/L_e) \\ = \frac{L_e}{d} U\left(\frac{d}{L_e}\right) \quad (38)$$

where

$$U\left(\frac{d}{L_e}\right) = \frac{d}{L_e} \left\{ p_t + \frac{p_r}{(1-p)} \exp\left(-\frac{d}{L_e}\right) \right\} \quad (39)$$

and

$$U\left(\frac{d}{L_e}\right) \approx \left[1 - \exp\left(-\frac{d}{L_e}\right) \right]^{1/2}. \quad (40)$$

Therefore, the external quantum efficiency (η₀) associated with internal photoemission can be concluded from (1), (24), (34), and (38) to be

$$\eta_0 \approx A_T \frac{L_e}{d} U\left(\frac{d}{L_e}\right) \frac{[(h\nu - \phi_B)^2 + (kT\pi)^2/3]}{8E_{ef}^{1/2}(kT)^{3/2}I(E_{ef})}. \quad (41)$$

D. Numerical Method

A computer program, which incorporates (1) to (24), (40), and (41), is run interactively to obtain the optimal agreement with the experimental results. The optical parameters used in the above calculation are assumed to be relatively constant over the wavelength range under consideration, and are in good agreement with results reported in [7], [10], [12]-[14]. φ_B is measured independently and L_e and E_{ef} are adjusted to obtain the best fit to experimental data; their final values are summarized in Table II and will be discussed in the following sections.

EXPERIMENTAL PROCEDURE

A. Fabrication

n-type germanium wafers of (111) orientation with 0.1-1.0 Ω·cm resistivity were used in this study; these were etched in CP-4A solution for 8 min prior to metal evaporation. Ohmic contacts were made by evaporating a thick film of high purity tin at the back of the slices. All metal evaporations were per-

formed in a liquid-nitrogen baffled oil-diffusion system with base pressure not greater than 8 × 10⁻⁶ torr. Deposition of the metal electrodes was through an "out-of-contact" mask to give several circular contacts (area ≈ 8.11 × 10⁻³ cm²) on each wafer. Metal thicknesses were monitored by an Edwards F.T.M. 2 film thickness monitor; these thicknesses were in the range from 50 to 1000 Å.

B. Electrical Measurements (C-V, I-V) in Darkness

Current-voltage (I-V) characteristics were plotted using a variable dc power supply and x-y recorder with the device in darkness. Capacitance-voltage data (C-V) at 1 MHz was measured using a Boonton Model 72 B capacitance meter again under dark conditions. C-V data were then transcribed to 1/C² versus V plots to obtain the barrier heights (φ_B) and doping density (N_d).

C. Photoresponse Measurements in the Infrared Region

1 μm < λ ≤ 2 μm

A SPEX model 1670 grating monochromator with resolution ~10⁻⁴ eV was used to generate the optical signal in the range 1 μm < λ ≤ 2 μm. A Corning RG 1000 D filter was used to eliminate radiation due to higher order diffraction. The optical power density (p_i) on the device at different λ was calibrated by an Epply linear thermopile (No. 15043). The short-circuit (V = 0) photogenerated current (I_{sc}) of the device was measured by a GR 1807 dc nanoammeter. The quantum efficiency for V = 0 is calculated as

$$\eta_0 = \left(\frac{I_{sc}}{qp_i a} \frac{1.24}{\lambda} \times 100 \right) \text{ percent} \quad (42)$$

where a is the device area.

RESULTS AND DISCUSSION

The results for the I-V and C-V characteristics for the metal-Ge Schottky barriers have been discussed in detail in our previous work [5], [6]. We summarize the typical results for those devices used for the present analysis in Table III. These devices have demonstrated very nearly ideal I-V characteristics with n values very close to unity. φ_B's determined from I-V and C-V measurement are in good agreement within an error of ±0.03 eV. Shown in Fig. 5 are some typical data obtained for internal photoemission for a set of devices with metal thickness ≤ 350 Å.

Shown in Fig. 6 is η₀^{1/2} versus hν (expanded scale) for Cu-Ge Schottky barriers at three different metal electrode thick-

TABLE III
SUMMARY OF SCHOTTKY BARRIER HEIGHT (ϕ_B) MEASURED BY FOUR
DIFFERENT METHODS

| METAL THICKNESS (d) Å | ϕ_B (eV) | | | | | | | | | | | | | | | |
|-----------------------------|------------------|------|-------|------|------------------|-------|------|------|-------|-------|------|-------|---------------|------|-------|-------|
| | FORWARD I - V | | | | REVERSE I - V | | | | C - V | | | | PHOTORESPONSE | | | |
| | Au | Ag | Cu | Pb | Au | Ag | Cu | Pb | Au | Ag | Cu | Pb | Au | Ag | Cu | Pb |
| 50 | 0.55 | | | | 0.55 | | | | 0.57 | | | | 0.56 | | | |
| 100 | 0.565 | 0.55 | 0.527 | | 0.545 | 0.54 | 0.5 | | 0.54 | 0.53 | 0.51 | | 0.55 | 0.54 | 0.512 | |
| 200 | | 0.55 | | | | 0.54 | | | | 0.53 | | | | 0.54 | | |
| 300 | | 0.56 | 0.5 | 0.55 | | 0.535 | 0.5 | 0.53 | | 0.525 | 0.48 | 0.525 | | 0.54 | 0.493 | 0.535 |
| 500 | | | 0.499 | | | | 0.5 | | | | | 0.483 | | | 0.49 | |
| 750 | | | 0.512 | | | | 0.51 | | | | | 0.5 | | | 0.49 | |

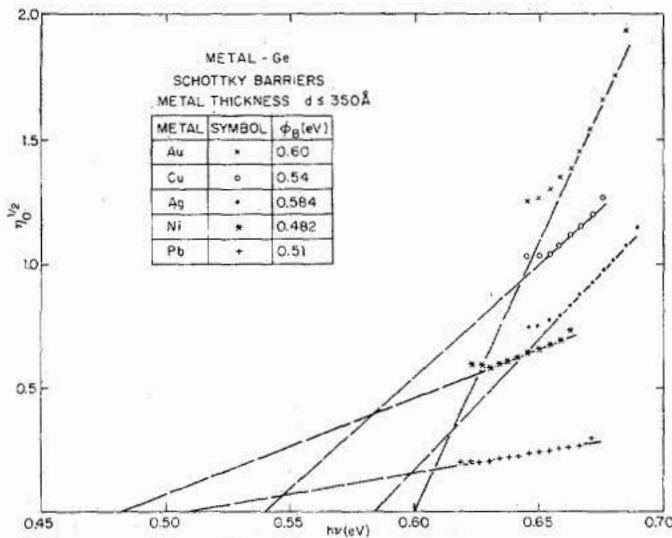


Fig. 5. Raw photoresponse data for a set of metal-Ge Schottky barriers with metal thickness $d \leq 350$ Å. ϕ_B , in the table of the insert, is obtained by the empirical relation $\eta_0^{1/2} \propto (h\nu - \phi_B)$.

nesses. These data are well fitted by straight lines which intersect the $h\nu$ axis at the same threshold ($\phi_B = 0.49$ eV). This demonstrates the tendency of photoresponse measurements to yield more consistent ϕ_B 's for different metal electrode thicknesses than the I - V and C - V methods.

In Fig. 7, we show the results of our analysis for a Pb-Ge Schottky barrier with $d = 300$ Å and $\phi_B = 0.535$ eV. Solid curves are the theoretical calculations for different values of hot electron mean free path (L_e). Good agreement with experimental results is obtained at $L_e = 55$ Å, and $E_{ef} = 0.1$ eV. Shown in Fig. 8 is the analysis of Au-Ge Schottky barriers with $d = 50$ and 100 Å, respectively. Good agreement of theory with experimental data is obtained at $L_e = 550$ Å and $E_{ef} = 0.1$ eV for both devices.

Fig. 9 shows a similar analysis for Ag-Ge Schottky barriers with $d = 100, 200,$ and 300 Å. All three devices demonstrate good agreement with theory for the same L_e (570 Å), E_{ef} (0.152 eV), and ϕ_B (0.54 eV). Shown in Fig. 10 is the analysis for Cu-Ge Schottky barriers with $d = 100$ and 300 Å. Again good agreement of theory with experimental data is obtained at $L_e = 450$ Å and $E_{ef} = 0.11$ eV for both devices. The 300 Å

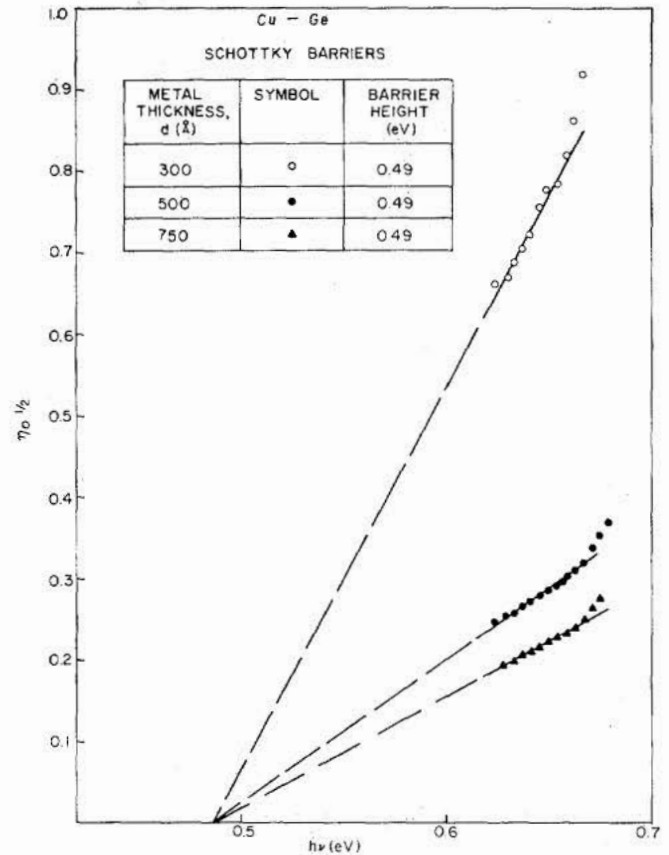


Fig. 6. Experimental results of $\eta_0^{1/2}$ versus $h\nu$ for Cu-Ge Schottky barrier at three different metal thicknesses. All three devices show good agreement for ϕ_B and their results are fit well by three straight lines.

Cu-Ge contact of Fig. 10 is the same as the 300 Å Cu-Ge contacts of Fig. 6. ϕ_B from Fig. 10 for this device is approximately 0.49 eV.

It is apparent from the present experimental results that the photoemission occurs from a narrow range of energy on the order of a fraction of an electron volt below the Fermi level; this is consistent with a density of states in the thin metal film which shows a narrow peak in this energy range. The work of Berglund and Spicer [9] on thick copper and silver films indicates that narrow peaks of this nature may be present near the Fermi energy and that broader peaks (Van Hove singularities)

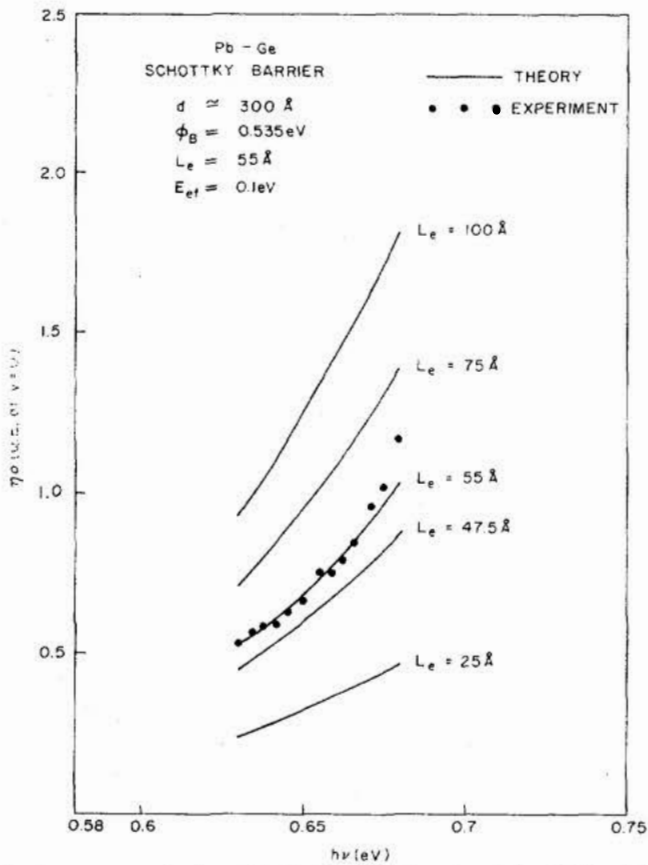


Fig. 7. η_0 versus $h\nu$ for a Pb-Ge Schottky barrier at $d = 300 \text{ \AA}$. Solid curves represent computer calculations for different mean free paths (L_e). The best fit to the experimental data is obtained at $L_e = 55 \text{ \AA}$, $\phi_B = 0.535 \text{ eV}$, and $E_{ef} = 0.10 \text{ eV}$.

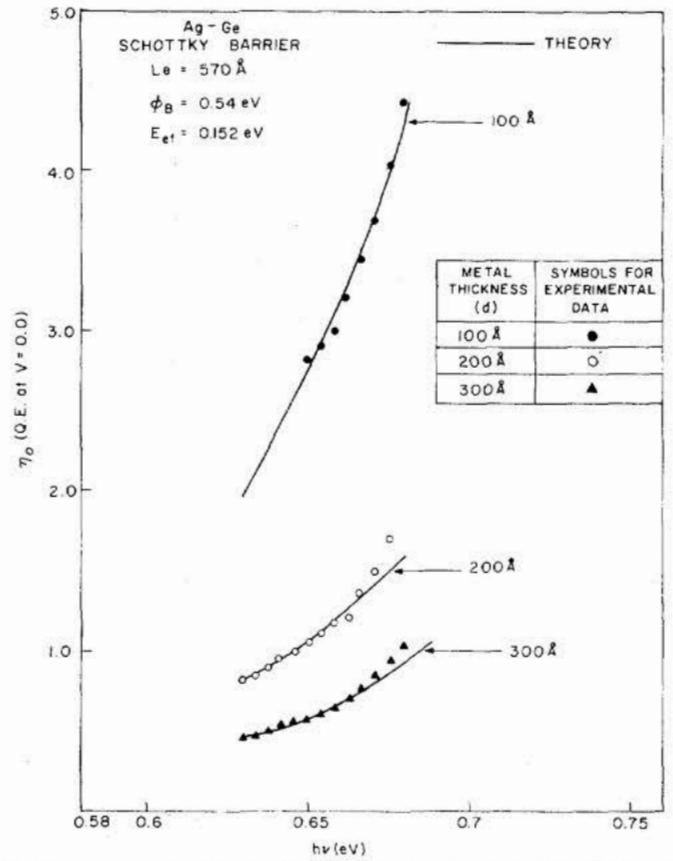


Fig. 9. η_0 versus $h\nu$ for Ag-Ge Schottky barrier at $d = 100, 200,$ and 300 \AA . Good agreement of theory with experimental data is obtained at $L_e = 570 \text{ \AA}$, $E_{ef} = 0.152 \text{ eV}$, and $\phi_B = 0.54 \text{ eV}$, for all three devices.

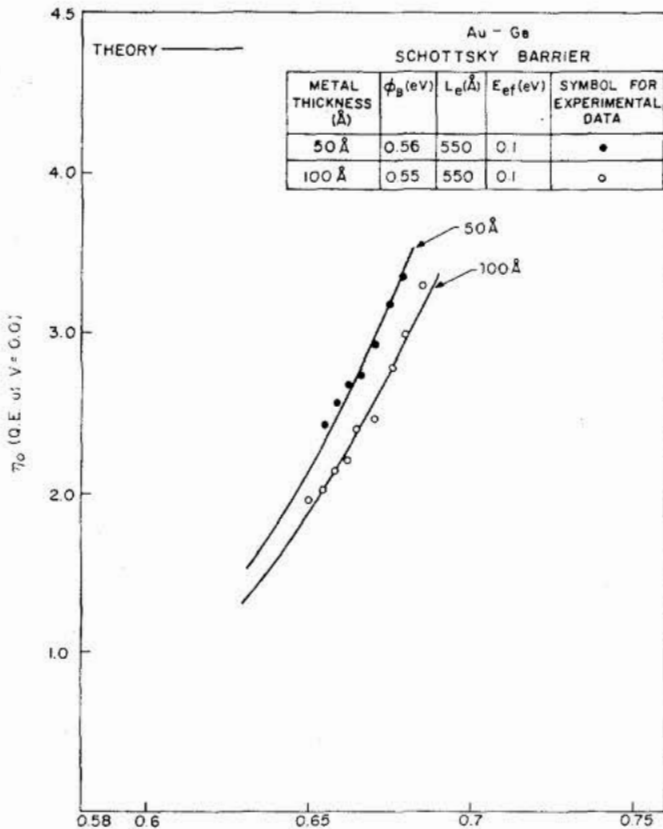


Fig. 8. η_0 versus $h\nu$ for Au-Ge Schottky barrier at $d = 50$ and 100 \AA . Good agreement of theory with experimental data is obtained at $L_e = 550 \text{ \AA}$ and $E_{ef} = 0.1 \text{ eV}$.

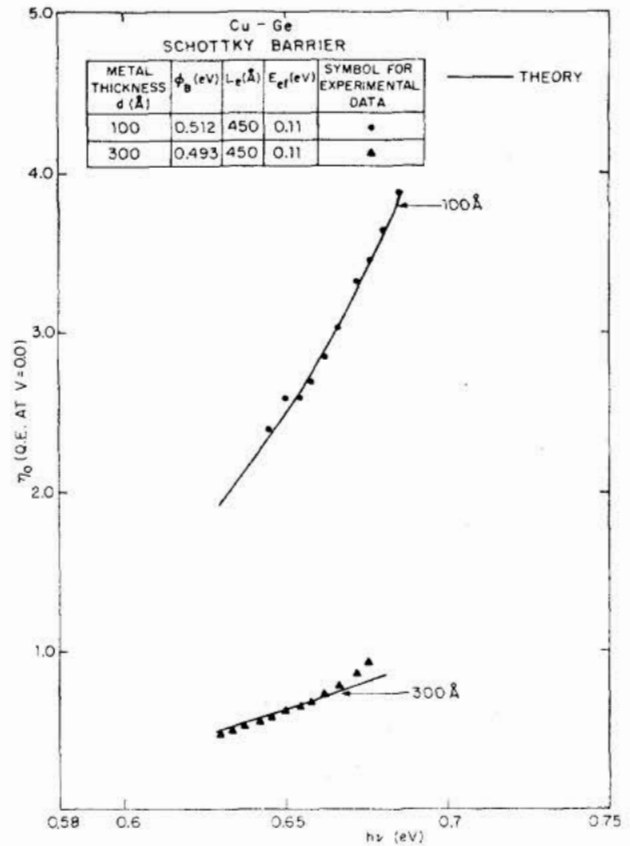


Fig. 10. η_0 versus $h\nu$ for Cu-Ge Schottky barrier at $d = 100$ and 300 \AA . Good agreement of theory with experimental data is obtained at $L_e = 450 \text{ \AA}$ and $E_{ef} = 0.11 \text{ eV}$.

are present at energies (several electron volts) well below the Fermi level. These lower lying states, however, are not accessible to photoemission for the range of energies (0.6–0.7 eV) employed here.

CONCLUSION

The quantum efficiency of thin metal film-Ge Schottky barriers associated with the photoemission of electrons from the metal can be explained by considering: 1) those photoexcited electrons in the metal which have sufficient kinetic energy normal to the metal-Ge interface to overcome ϕ_B , and induced by uniform absorption of the incident photons, 2) multiple scattering of hot electrons in the metal, and 3) multiple reflection of transmitted photons in the Ge substrate. The theoretical model presented here is consistent with the experimental data insofar as the hot electron mean free path (L_e) and effective Fermi-energy (E_{ef}) deduced from the comparison of theory and experiment is independent of metal thickness for each type of metal-Ge contact. E_{ef} is quite small (≈ 0.1 eV) which implies that the 0.6–0.7 eV photons excite electrons from the near-neighborhood of the Fermi energy level, in qualitative agreement with the density of states distributions of Berglund and Spicer [9]. Internal photoemission in thin metal films is relatively well understood by the present theoretical description which is expected to enable the optimization of Schottky barrier detectors operating in this mode. This mechanism provides an extension to longer wavelength operation (beyond the normal cutoff associated with the energy gap of the semiconductor) of metal-Ge Schottky barrier quantum detectors.

ACKNOWLEDGMENT

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REFERENCES

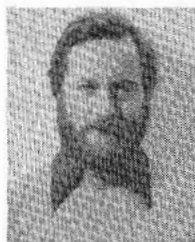
- [1] K. S. Chaplin and G. Eisenstein, "Infrared response of lightly doped Schottky diodes," *Appl. Phys. Lett.*, vol. 31, p. 221, Aug. 1977.
- [2] A. A. Gutkin, M. V. Dmitriev, and V. M. Khair, "Photosensitivity of Au-n-Si surface-barrier diodes in the spectral range 1–6 eV," *Sov. Phys. Semicond.*, vol. 11, p. 290, Mar. 1977.
- [3] F. D. Shepherd, Jr. and A. C. Yang, "Silicon Schottky retinas for infrared imaging," *International Electron Devices Meeting (IEDM) Technical Digest*, pp. 310–313, Dec. 1973.
- [4] H. D. Law, L. R. Tomasetta, K. Nakano, and J. S. Harris, "1.0–1.4 μm high-speed avalanche photodiodes," *Appl. Phys. Lett.*, vol. 33, p. 416, Sept. 1978.
- [5] E. Y. Chan and H. C. Card, "Optoelectronic properties of metal-Ge Schottky barrier quantum detectors," *International Electron Devices Meeting (IEDM) Technical Digest*, pp. 653–656, Dec. 1978.
- [6] —, "Infrared optoelectronic properties of metal-Ge Schottky barriers," *IEEE Trans. Electron Devices*, vol. ED-27, pp. 78–83, Jan. 1980.
- [7] —, "Near infrared interband transitions and optical parameters of metal-Ge contacts," *Appl. Opt.*, to be published.
- [8] R. H. Fowler, "The analysis of photoelectronic sensitivity curves for clean metals at various temperatures," *Phys. Rev.*, vol. 38, p. 45, July 1931.
- [9] C. N. Berglund and W. E. Spicer, "Photoemission studies of copper and silver: Theory and experiment," *Phys. Rev.*, vol. 136, pp. A 1030–1064, Nov. 1964.
- [10] O. S. Heavens, "Optical properties of thin films," *Rep. Progress in Phys., Inst. Phys. and the Phys. Soc.*, London, England, 23, 1960, pp. 1–65.
- [11] V. E. Vickers, "Model of Schottky barrier hot-electron-mode photodetection," *Appl. Opt.*, vol. 10, pp. 2190–2192, Sept. 1971.
- [12] L. S. Schulz, "The optical constants of silver, gold, copper and aluminum: I. The absorption coefficient k ; II. The index of refraction n ," *J. Opt. Soc. Amer.*, vol. 44, pp. 357–370, May 1974.
- [13] L. G. Schulz, "An experimental confirmation of the drude free electron theory of the optical properties of metals for silver, gold and copper in the near infrared," *J. Opt. Soc. Amer.*, vol. 44, p. 540, May 1954.
- [14] H. M. O'Bryan, "The optical constants of several metals in vacuum," *J. Opt. Soc. Amer.*, vol. 26, p. 122, Mar. 1936.



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Notes and Lines

Correction to "Coherent Optical Processing: Another Approach"

In the table of contents of the December 1979 issue, the term "Invited Paper" was inadvertently omitted after the title of the above paper.¹

¹B. D. Guenther, C. R. Christensen, and J. Upatnieks, *IEEE J. Quantum Electron.*, vol. QE-15, pp. 1348-1362, Dec. 1979.

Book Reviews

Acousto-Optics—J. Sapriel (Translated by S. Francis and B. Kelly). (New York: Wiley, 1979, 126 pp., \$20.00). *Reviewed by M. D. Fox.*

This slender but ambitious monograph attempts to unify in a single volume a large number of topics, each of which could easily occupy textbooks in their own right. These topics include piezoelectricity, elasticity, photoelastic effects, bulk and surface acoustic wave propagation, acoustooptic interactions, and experimental determination of acoustic and acoustooptic properties of materials. The aim is to provide both a reference work for researchers and an introductory textbook for seniors or beginning graduate students. Given the broad sweep of the objectives and the small size of the volume, perhaps the author should be forgiven for not entirely achieving his goals.

The unifying theme for tying together the diverse physical phenomena described is a powerful tensor notation which is introduced in the first chapter. In succeeding chapters, elasticity theory, propagation of plane acoustic waves in piezoelectric and nonpiezoelectric media, and photoelastic properties of crystals are introduced using this tensor approach. Piezoelectricity is rather neatly introduced as an extension of the elastic description for nonpiezoelectric materials. These introductory theoretical chapters pave the way for the final three chapters discussing diffraction of light by acoustic waves, acoustooptic deflectors and modulators, and the determina-

tion of acoustic and acoustooptic characteristics of materials by experimental methods. The last three chapters differ markedly from the first five by emphasizing experimental results, and rarely employ the tensor notation introduced in the first five chapters. A final conclusion section is very brief.

In trying to cover so much ground, some topics are necessarily treated rather superficially. In the discussion of piezoelectric transducers, for example, the author presents a discussion of power transfer into transducers, but neglects the more important problem of maximizing bandwidth. He also omits mention of the large body of engineering literature on the subject of transducer design. The discussion on the determination of elastic and piezoelectric constants by resonance measurements is very brief and ignores such significant practical problems as variation of dielectric constant with frequency, and the existence of spurious resonances, which are particularly prominent in plates vibrating in air.

Overall, the author was probably wise to emphasize a phenomenological description of the various effects covered, and to avoid delving into the microscopic theories, whose validity may be questionable. However, by introducing a very general tensor notation, many of the theoretical discussions are so general as to be very abstract and difficult for the introductory student to visualize. Thus, despite the solved exercises, it seems to me that the book would be difficult to use as a text. As a reference for those working in the field, it does bring together a large body of material in a concise way under a unified notation.